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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q66212

KIYOKU, HIROYUKI, et al.

Appln. No.: 09/986,332

Group Art Unit: 1722

Confirmation No.: 5542

Examiner: Matthew A. ANDERSON

Filed: November 08, 2001

For: NITRIDE SEMICONDUCTOR GROWTH METHOD, NITRIDE SEMICONDUCTOR SUBSTRATE,
AND NITRIDE SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of July 5, 2005 from October 5, 2005 to December 5, 2005.

A check for the statutory fee of \$450.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

12/06/2005 HALI11 00000028 09986332

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450.00 DP

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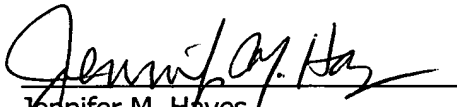
WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: December 5, 2005

Respectfully submitted,


Jennifer M. Hayes
Registration No. 40,641